

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

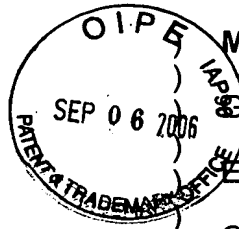
In re Patent Application of

Kari Harkonen et al.

Application No.: 10/642,426

Filed: August 15, 2003

For: DEPOSITION OF CARBON- AND  
TRANSITION METAL-CONTAINING  
THIN FILMS



MAIL STOP AMENDMENT

Group Art Unit: 1762

Examiner: BRET P. CHEN

Confirmation No.: 9896

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 7, 2006, please amend the  
above-identified patent application as follows: